

<b>Notice of References Cited</b>	Application/Control No. 09/744,904	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner Rip A. Lee	Art Unit 1713	Page 1 of 1


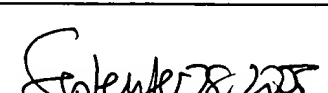
**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP 10-017617 A	01-1998	Japan	Yamaguchi et al.	C08F 10/02
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**NON-PATENT DOCUMENTS**

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